

325-118

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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

31080 U.S. PTO  
10/01/2001  
12/18/01

APPL NUM 10017384	FILING DATE 12/18/2001	CLASS 204 437	SUBCLASS 242	CAH 174 1752	EXAMINER VALENTINE
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204

\*\*CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/674,179 10/27/2000, 6517,894

\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN 10-136151 04/30/1998

JAPAN 10-136152 04/30/1998

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 2001-1846
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		
Verified and Acknowledged Examiners's initials		
TITLE : Substrate plating method and apparatus		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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